

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: DAVID Q. WRIGHT  
APPLICATION No.: 10/057,600  
FILED: JANUARY 24, 2002  
FOR: **PLANARIZING MACHINES AND METHODS  
FOR MECHANICAL AND/OR CHEMICAL-  
MECHANICAL PLANARIZATION OF  
MICROELECTRONIC-DEVICE SUBSTRATE  
ASSEMBLIES**

EXAMINER: GEORGE A. GOUDREAU  
ART UNIT: 1763  
CONF. No: 3689

**Resubmission of Reference Cited in Information Disclosure Statement**  
**Filed on March 6, 2003**

Mail Stop Non-Fee Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

The enclosed reference was cited in an Information Disclosure Statement filed with the U.S. Patent and Trademark Office on March 6, 2003 for the above-referenced application, but the Examiner indicated that the cited reference was unavailable. Applicant herewith resubmits this reference for official consideration by the Examiner. Applicant has enclosed a copy of page 7 of the Form PTO/SB/08A filed on March 6, 2003 for the Examiner to initial indicating consideration of the enclosed reference.

No fees are believed due because the reference was previously submitted, however, should the Commissioner determine that fees are due in order for this reference to be considered, the Commissioner is hereby authorized to charge such fees to Deposit Account No. 50-0665.

If the Examiner has any questions, he is requested to contact David T. Dutcher at (206) 359-6465.

Respectfully submitted,  
Perkins Coie LLP

David T. Dutcher  
Registration No. 51,638

Date: Dec. 18, 2003

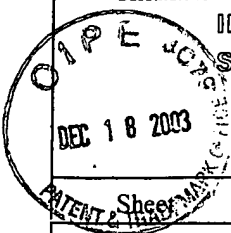
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PTO/SB/08A

Approved for use through 10/31/99. OMB 0651-0031  
Patent and Trademark Office: U.S. DEPARTMENT OF COMMERCE



Substitute for form 1449A/PTO

**INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT**  
(use as many sheets as necessary)

**COMPLETE IF KNOWN**

Application Number	10/057,600
Confirmation Number	3689
Filing Date	January 24, 2002
First Named Inventor	David Q. Wright
Group Art Unit	1763
Examiner Name	George A. Goudreau
Attorney Docket No.	108298508US1

**U.S. PATENT DOCUMENTS**

*EXAMINER INITIALS*	Cite No.	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		NUMBER	Kind Code (if known)			
		6,364,746B2		Moore	04/02/02	
		6,364,757B2		Moore	04/02/02	
		6,368,190B1		Easter et al.	04/09/02	
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		6,376,381B1		Sabde	04/23/02	

**FOREIGN PATENT DOCUMENTS**

*EXAMINER INITIALS*	Cite No.	Foreign Patent Document			Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T
		Office	Number	Kind Code (if known)				

**OTHER PRIOR ART-NON PATENT LITERATURE DOCUMENTS**

*EXAMINER INITIALS*	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume/issue number(s), publisher, city and/or country where published.	T
		SEIICHI KONDO, NORIYUKI SAKUMA, YOSHIO HOMMA, YASUSHI GOTO, NAOFUMI Ohashi, Hizuru Yamaguchi, and Nobuo Owada, "Abrasive-Free Polishing for Copper Damascene Interconnection", <i>Journal of the Electrochemical Society</i> , 147 (10) pp. 3907-3913 (2000)	

EXAMINER

DATE CONSIDERED

\* EXAMINER: Initial if reference considered, whether or not criteria is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant(s).